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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet	1	of	2
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Complete if Known

Application Number	09/678,266
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Filing Date	10/3/2000
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First Named Inventor	Ming Xi
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Group Art Unit	1702 2827
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Examiner Name	unassigned
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Attorney Docket Number	4714P1/AMI-11
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U.S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

[illegible]Examiner
Signature

Date	
Considered	

8/6/2

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¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

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Publication Number	09/678,266
Filing Date	10/3/2000
First Named Inventor	Ming Xi
Group Art Unit	1702 2822
Examiner Name	unassigned - 2A22ERE
Attorney Docket Number	4714P1/AMI-11

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

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Examiner Signature	<i>Kevin H. Farnish</i>	Date Considered	8/6/2
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U.S. Department of Commerce, Patent and Trademark Office		Docket No.	Serial No.
(PTO Form 1449 modified)		APPM/4714.P1	09/678,266
LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT		Applicant Kori, et al.	Confirmation No. 4642
(Use several sheets if necessary)		Filing Date	Group
Examiner Zameke, D.		10/03/2000	2827

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*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
QH	A1	2001/0042799 A1	11/22/2001	Kim, et al.	239	553	02/02/2001
	A2						
	A3						
	A4						
	A5						
	A6						
	A7						
	A8						
	A9						
	A10						
	A11						
	A12						

Foreign Patent Documents

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	B2						<input type="checkbox"/>	<input type="checkbox"/>

OTHER ART

*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
QH	C1	"Cluster Tools for Fabrication of Advanced Devices" Jap. J of Applied Physics, Extended Abstracts 22 nd Conference Solid State Devices and Materials (1990), pp. 849- 852
QH	C2	Kitigawa, et al., "Hydrogen-mediated low temperature epitaxy of Si in plasma-enhanced chemical vapor deposition", Applied Surface Science (2000), pp. 30-34
QH	C3	Lee, et al., "Pulsed nucleation for ultra-high aspect ratio tungsten plugfill", Novellus Systems, Inc. (2001), pp. 1-2 (COPY NOT AVAILABLE TO APPLICANT AT THIS TIME)

Examiner	Date Considered 8/6/2
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U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)		Docket No. AMAT/4714.P1	Serial No. 09/678,266
LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT		Applicant Xi, et al.	
(Use several sheets if necessary)		Filing Date October 03, 2000	Group 1762 2825
Examiner Unknown			

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*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
DA	A1	4,486,487	12/04/84	Skarp	428	216	04/25/1983
DA	A2	4,829,022	05/09/89	Kobayashi et al.	437	107	12/09/1986
DA	A3	4,834,831	05/30/89	Nishizawa et al.	156	611	09/04/1987
DA	A4	4,838,983	06/13/89	Schumaker et al.	156	613	03/18/1988
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DA	A6	4,859,625	08/22/89	Nishizawa et al.	437	81	11/20/1987
DA	A7	4,927,670	05/22/1990	Erbil	427	255.3	06/22/1988
DA	A8	4,931,132	06/05/90	Aspnes et al.	156	601	10/07/1988
DA	A9	4,960,720	10/02/90	Shimbo	437	105	08/24/1987
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DA	A11	5,013,683	05/07/91	Petroff et al.	437	110	01/23/1989
DA	A12	5,085,885	02/04/92	Foley et al.	477	38	09/10/1990
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DA	B2	01/40541 A1	06/07/2001	WO	C23C	16/40		X
DA	B3	01/36702 A1	05/25/2001	WO	C23C	16/00		X
DA	B4	01/29893 A1	04/26/2001	WO	H01L	21/768		X
DA	B5	01/29891 A1	04/26/2001	WO	H01L	21/768		X

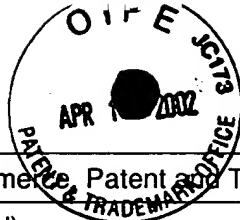
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DA	C1	Hultman, et al., "Review of the thermal and mechanical stability of TiN-based thin films", <i>Zeitschrift Fur Metalkunde</i> , 90(10) (Oct. 1999), pp. 803-813.
DA	C2	Klaus, et al., "Atomic Layer Deposition of SiO ₂ Using Catalyzed and Uncatalyzed Self-Limiting Surface Reactions", <i>Surface Review & Letters</i> , 6(3&4) (1999), pp. 435-448.

Examiner

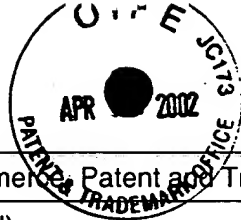
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LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT					Applicant Xi, et al.			
(Use several sheets if necessary)					Filing Date October 03, 2000		Group 162, 282, 2002	
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DL	A14	5,246,536	09/21/93	Nishizawa et al.	156	610	03/10/1989	
DL	A15	5,254,207	10/19/93	Nishizawa et al.	156	601	11/30/1992	
DL	A16	5,296,403	03/22/94	Nishizawa et al.	437	133	10/23/1992	
DL	A17	5,311,055	05/10/94	Goodman et al.	257	593	11/22/1991	
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DL	A22	5,439,876	08/08/95	Graf et al.	505	447	08/16/1993	
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							YES	NO
DL	B6	01/29280 A1	04/26/2001	WO	C23C	16/32		X
DL	B7	01/27347 A1	04/19/2001	WO	C23C	16/44		X
DL	B8	01/27346 A1	04/19/2001	WO	C23C	16/44		X
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*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.						
DL	C3	Yamaguchi, et al., "Atomic-layer chemical-vapor-deposition of silicon dioxide films with extremely low hydrogen content", <i>Appl. Surf. Sci.</i> , Vol. 130-132 (1998), pp. 202-207.						
DL	C4	George et al., "Surface Chemistry for Atomic Layer Growth", <i>J. Phys. Chem.</i> , Vol. 100 (1996), pp. 13121-131.						
Examiner					Date Considered			
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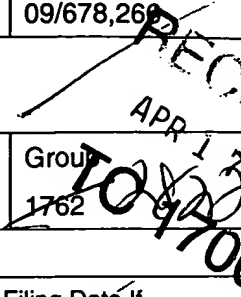


U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)					Docket No. AMAT/4714.P1		Serial No. 09/678,266	
LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT					Applicant Xi, et al.			
(Use several sheets if necessary)					Filing Date October 03, 2000		Group 1 7 2002 1062 2828 1700	
Examiner Unknown								
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DA	A28	5,521,126	05/28/96	Okamura et al.	437	235	06/22/1994	
DA	A29	5,527,733	06/18/96	Nishizawa et al.	437	160	02/18/1994	
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DA	A35	5,707,880	01/13/98	Aftergut et al.	437	3	01/17/1997	
DA	A36	5,747,113	05/05/98	Tsai	427	255.5	07/29/1996	
DA	A37	5,749,974	05/12/98	Habuka et al.	118	725	07/13/1995	
DA	A38	5,796,116	08/18/98	Nakata et al.	257	66	07/25/1995	
DA	A39	5,807,792	09/15/98	Ilg et al.	438	758	12/18/1996	
DA	A40	5,830,270	11/03/98	McKee et al.	117	106	08/05/1996	
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*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
DA	B10	00/79576 A1	12/28/2000	WO	H01L	21/205		X
DA	B11	00/79019 A1	12/28/2000	WO	C23C	16/00		X
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*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.						
DA	C5	George, et al., "Atomic layer controlled deposition of SiO ₂ and Al ₂ O ₃ using ABAB... binary reaction sequence chemistry", <i>Appl. Surf. Sci.</i> , Vol. 82/83 (1994), pp. 460-467.						
DA	C6	Wise, et al., "Diethyldiethoxysilane as a new precursor for SiO ₂ growth on silicon", <i>Mat. Res. Soc. Symp. Proc.</i> , Vol. 334 (1994), pp. 37-43.						
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LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT					Applicant Xi, et al.			
(Use several sheets if necessary)					Filing Date October 03, 2000		Group 1 G789 2800	
Examiner Unknown								
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*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date if Appropriate	
[Signature]	A41	5,835,677	11/10/98	Li et al.	392	401	10/03/1996	
[Signature]	A42	5,855,675	01/05/99	Doering et al.	118	719	03/03/1997	
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[Signature]	A45	5,904,565	05/18/1999	Nguyen, et al.	438	687	07/17/1997	
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[Signature]	A47	5,923,056	07/13/99	Lee et al.	257	192	03/12/1998	
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[Signature]	A50	5,942,040	08/24/99	Kim et al.	118	726	08/27/1997	
[Signature]	A51	5,947,710	09/07/1999	Cooper, et al.	418	63	06/16/1997	
[Signature]	A52	5,972,430	10/26/99	DiMeo, Jr. et al.	427	255.32	11/26/1997	
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[Signature]	A54	6,174,377	01/16/2001	Doering, et al.	118	729	01/04/1999	
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*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
[Signature]	B13	00/54320 A1	09/14/2000	WO	H01L	21/44		X
[Signature]	B14	00/16377 A2	03/23/2000	WO	H01L	---		X
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*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.						
[Signature]	C7	Niinisto, et al., "Synthesis of oxide thin films and overlayers by atomic layer epitaxy for advanced applications", <i>Mat. Sci. & Eng.</i> , Vol. B41 (1996), pp. 23-29.						
[Signature]	C8	Ritala, et al., "Perfectly conformal TiN and Al ₂ O ₃ films deposited by atomic layer deposition", <i>Chemical Vapor Deposition</i> , Vol. 5(1) (January 1999), pp. 7-9.						
Examiner [Signature]					Date Considered 1/16/02			
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(Use several sheets if necessary)					Filing Date October 03, 2000		Group 1762	
Examiner Unknown					APR 12 2002 O I P E PATENT & TRADEMARK OFFICE			
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*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate	
	A55	6,174,809	01/16/2001	Kang, et al.	438	682	12/15/1998	
	A56	6,203,613	03/20/2001	Gates, et al.	117	104	10/19/1999	
	A57	6,207,302	03/27/2001	Sugiura, et al.	428	690	03/02/1998	
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	A62	6,305,314	10/23/2001	Sneh, et al.	118	723 R	12/17/1999	
	A63	6,306,216	10/23/2001	Kim, et al.	118	725	07/12/2000	
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	A66	2001/0009140	07/26/2001	Bondestam, et al.	118	725	01/25/2001	
	A67	2001/0011526	08/09/2001	Doering, et al.	118	729	01/16/2001	
Foreign Patent Documents								
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							YES	NO
	B16	99/41423 A2	08/19/1999	WO	C23C	---		X
	B17	96/18756 A1	06/20/1996	WO	C23C	16/08		X
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*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.						
	C9	Min, et al., "Atomic layer deposition of TiN thin films by sequential introduction of Ti precursor and NH/sub3", <i>Symp.: Advanced Interconnects and Contact Materials and Processes for Future Integrated Circuits</i> (Apr. 13-16, 1998), pp. 337-342.						
	C10	Klaus, et al., "Atomic Layer Deposition of Tungsten using Sequential Surface Chemistry with a Sacrificial Stripping Reaction," <i>Thin Solid Films</i> 360 (2000), Pages 145 - 153, (Accepted Nov. 16, 1999).						
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LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT					Applicant Xi, et al.			
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U.S. Patent Documents							
*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
[Signature]	A68	2001/0031562	10/18/2001	Raaijmakers, et al.	438	770	02/22/2001
	A69	2001/0034123	10/25/2001	Jeon, et al.	438	643	04/06/2001
	A70						
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	B19	93/02111 A1	02/04/1993	WO	C08F	4/78		X
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[Signature]	C11	Min, et al., "Metal-Organic Atomic-Layer Deposition of Titanium-Silicon-Nitride Films", <i>Applied Physics Letters</i> , American Inst. Of Physics, Vol 75(11) (Sept. 13, 1999).
	C12	Martensson, et al., "Atomic Layer Epitaxy of Copper on Tantalum", <i>Chemical Vapor Deposition</i> , 3(1) (Feb. 1, 1997), pp. 45-50.
Examiner [Signature]		Date Considered 8/6/02

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U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)				Docket No. AMAT/4714.P1		Serial No. 09/678 266	
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Examiner Unknown							

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	A77					
	A78					
	A79					
	A80					

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	C13 Ritala, et al. "Atomic Layer Epitaxy Growth of TiN Thin Films", <i>J. Electrochem. Soc.</i> , 142(8) (Aug. 1995), pp. 2731-737.
	C14 Elers, et al., "NbC15 as a precursor in atomic layer epitaxy", <i>Appl. Surf. Sci.</i> , Vol. 82/83 (1994), pp. 468-474.
	C15 Lee, "The Preparation of Titanium-Based Thin Film by CVD Using Titanium Chlorides as Precursors", <i>Chemical Vapor Deposition</i> , 5(2) (Mar. 1999), pp. 69-73.
	C16 Martensson, et al., "Atomic Layer Epitaxy of Copper, Growth & Selectivity in the Cu (II)-2,2,6,6-Tetramethyl-3, 5-Heptanedione ATE/H2 Process", <i>J. Electrochem. Soc.</i> , 145(8) (Aug. 1998), pp. 2926-2931.

Examiner	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.


U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)				Docket No. AMAT/4714.P1		Serial No. 09/678,266	
LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT				Applicant Xi, et al.			
(Use several sheets if necessary)				Filing Date October 03, 2000		Group 1762	
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U.S. Patent Documents							
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	B32	196 27 017	01/09/1997	DE	H01L	21/283	X
	B33	2 626 110	07/21/1989	FR	H01L	39/24	X
	B34	2 692 597	12/24/1993	FR	C23C	16/00	X
	B35	2 355 727	05/02/2001	GB	C23C	16/44	X
OTHER ART							
*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.					
	C17	Min, et al., "Chemical Vapor Deposition of Ti-Si-N Films with Alternating Source Supply", <i>Mat., Res. Soc. Symp. Proc.</i> , Vol. 564 (Apr. 5, 1999), pp. 207-210					
	C18	Bedair, "Atomic layer epitaxy deposition processes", <i>J. Vac. Sci. Technol.</i> 12(1) (Jan/Feb 1994)					
	C19	Yamaga, et al., "Atomic layer epitaxy of ZnS by a new gas supplying system in a low-pressure metalorganic vapor phase epitaxy", <i>J. of Crystal Growth</i> 117 (1992), pp. 152-155					
	C20	Elam, et al., "Nucleation and growth during tungsten atomic layer deposition on SiO ₂ surfaces," <i>Thin Solid Films</i> 386 (2001) Pages 41 - 52, (Accepted Dec. 14, 2000).					
Examiner				Date Considered			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.							

U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)					Docket No. APPM/4714.P1		Serial No. 09/678,266	
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Examiner <i>David H. Zamb</i>					Date Considered <i>8/6/2</i>			
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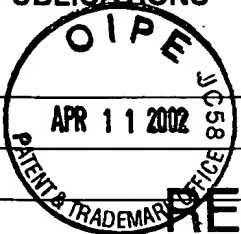
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Examiner <i>TC</i>	Date Considered <i>8/6/02</i>
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U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)				Docket No. APPM/4714.P1		Serial No. 09/678,266	
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Examiner <i>Paul H. Paul</i>					Date Considered <i>8/6/2</i>		
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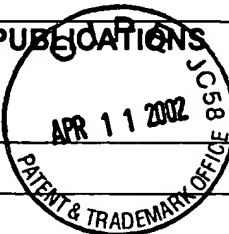
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Examiner *Smith, J.* Date Considered *8/16/12*

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U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)					Doc. No. APPM/4714.P1		Serial No. 09/678,266	
SUPPLEMENTAL LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT					Applicant Kori, et al.		Confirmation No.: Unknown	
(Use several sheets if necessary)					Filing Date October 30, 2000		Group 1762 2827	
Examiner Unknown								



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*Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						YES	NO
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Examiner <i>David A. Funch</i>	Date Considered 8/6/12
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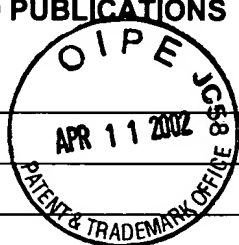
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U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)		Docket No. APPM/4714.P1	Serial No. 09/678,266
SUPPLEMENTAL LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT		Applicant Kori, et al.	Confirmation No.: Unknown
(Use several sheets if necessary)		Filing Date October 30, 2000	Group 1782 2827
Examiner Unknown			
OTHER ART			
*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.	
PH	C1	Ohba, et al., "Thermal Decomposition of Methylhydrazine and Deposition Properties of CVD TiN Thin Films", Conference Proceedings, Advanced Metallization for ULSI Applications in 1993 (1994), pp. 143-149	
PH	C2	Scheper, et al., "Low-temperature deposition of titanium nitride films from dialkylhydrazine-based precursors", Materials Science in Semiconductor Processing 2 (1999), pp. 149-157	
PH	C3	Suzuki, et al., "A 0.2- μ m contact filing by 450°C-hydrazine-reduced TiN film with low resistivity", IEDM 92-979, pp. 11.8.1 – 11.8.3	
PH	C4	Suzuki, et al., "LPCVD-TiN Using Hydrazine and TiCl ₄ ", VMIC Conference (June 8-9, 1993), pp. 418-423	
PH	C5	IBM Tech. Disc. Bull. "Knowledge-Based Dynamic Scheduler in Distributed Computer Control, (June 1990), pp. 80-84	
PH	C6	IBM Tech. Disc. Bull. "Multiprocessor and Multitasking Architecture for Tool Control of the Advanced via Inspection Tools" (May 1992), pp. 190-191	
PH	C7	McGeachin, S., "Synthesis and properties of some β -diketimines derived from acetylacetone, and their metal complexes", Canadian J. of Chemistry, Vol. 46 (1968), pp.1903-1912	
PH	C8	Solanki, et al., "Atomic Layer deposition of Copper Seed Layers", Electrochemical and Solid State Letters, 3(10) (2000), pp. 479-480	
PH	C9	NERAC.COM Retro Search: Atomic Layer Deposition of Copper, dated October 11, 2001	
PH	C10	NERAC.COM Retro Search: Atomic Layer Deposition / Epitaxy Aluminum Oxide Plasma, dated October 2, 2001	
PH	C11	NERAC Search abstract of "Atomic Layer deposition of Ta and Ti for Interconnect Diffusion Barriers", by Rossnagel, et al., J. Vac. Sci. & Tech., 18(4) (July 2000)	
PH	C12	Abstracts of articles re atomic layer deposition	
PH	C13	Abstracts of search results re atomic layer deposition, search dated January 24, 2002	
PH	C14	Abstracts of articles re atomic layer deposition and atomic layer nucleation	
PH	C15	Abstracts of articles re atomic layer deposition and semiconductors and copper	
Examiner <i>David H. Jurek</i>		Date Considered <i>8/6/02</i>	
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SUPPLEMENTAL LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT		APR 11 2002 PATENT & TRADEMARK OFFICE	Applicant Kori, et al.	Confirmation No.: Unknown
(Use several sheets if necessary)			Filing Date October 30, 2000	Group 1762 2827
Examiner Unknown				
OTHER ART				
*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.		
MAZ	C16	Abstracts of articles – atomic layer deposition		
MAZ	C17	NERAC Search – Atomic Layer Deposition, search dated October 16, 2001		
MAZ	C18	Bader, et al., "Integrated Processing Equipment", Solid State Technology, Cowan Pub., Vol. 33, No. 5 (May 1, 1990), pp. 149-154		
MAZ	C19	Choi, et al., "The effect of annealing on resistivity of low pressure chemical vapor deposited titanium diboride", J. Appl. Phys. 69(11) (June 1, 1991), pp. 7853-7861		
MAZ	C20	Choi, et al., "Stability of TiB ₂ as a Diffusion Barrier on Silicon", J. Electrochem. Soc. 138(10) (October 1991), pp. 3062-3067		
MAZ	C21	"Cluster Tools for Fabrication of Advanced devices" Jap. J. of Applied Physics, Extended Abstracts, 22 nd Conference Solid State Devices and Materials (1990), pp. 849 – 852 XP000178141 (ARTICLE ON ORDER – TO BE PROVIDED)		
MAZ	C22	"Applications of Integrated processing", Solid State Technology, US, Cowan Pub., Vol 37, No. 12 (December 1, 1994), pp. 45-47		
MAZ	C23	Kitigawa, et al., "Hydrogen-mediated low temperature epitaxy of Si in plasma-enhanced chemical vapor deposition", Applied Surface Science (2000), pp. 30-34 (ARTICLE ON ORDER – TO BE PROVIDED)		
MAZ	C24	Lee, et al., "Pulsed nucleation for ultra-high aspect ratio tungsten plugfill", Novellus Systems, Inc. (2001), pp. 1-2 (ARTICLE ON ORDER – TO BE PROVIDED)		
Examiner	David A. Zupnik		Date Considered 8/6/02	
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of

4

Application Number

09/678,866

Filing Date

10/03/2000

First Named Inventor

Ming Xi

Group Art Unit

~~1762~~ 2827

Examiner Name

Unassigned **ZARNEKE**

Attorney Docket Number

4714P1/AMI-11

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
<i>OK</i>	AJ	4,058,430		Suntola et al.	11-15-1977	
<i>OK</i>	AK	4,389,973		Suntola et al.	06-28-1983	
<i>OK</i>	AL	4,413,022		Suntola et al.	11-01-1983	
<i>OK</i>	AM	4,767,494		Kobayashi et al.	08-30-1988	
<i>OK</i>	AN	4,806,321		Nishizawa et al.	02-21-1989	
<i>OK</i>	AO	4,840,921		Matsumoto	06-20-1989	
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<i>OK</i>	AQ	4,859,627		Sunakawa	08-22-1989	
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<i>OK</i>	AZ	5,256,244		Ackerman	10-26-1993	
<i>OK</i>	BA	5,270,247		Sakuma et al.	12-14-1993	
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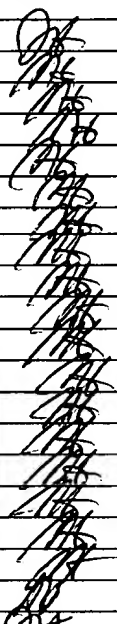
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Sheet 2 of 4

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Application Number	09/678,266
Filing Date	10/03/2000
First Named Inventor	Ming Xi
Group Art Unit	1762 782
Examiner Name	Unassigned
Attorney Docket Number	4714P1/AMI-11

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
	BD	5,290,748		Knuuttila et al.	03-01-1994	
	BE	5,294,286		Nishizawa et al.	03-15-1994	
	BF	5,300,186		Kitahara et al.	04-05-1994	
	BG	5,316,793		Wallace et al.	05-31-1994	
	BH	5,330,610		Eres et al.	07-19-1994	
	BI	5,336,324		Stall et al.	08-09-1994	
	BJ	5,338,389		Nishizawa et al.	08-16-1994	
	BK	5,395,791		Cheng et al.	03-07-1995	
	BL	5,443,033		Nishizawa et al.	08-22-1995	
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	BN	5,480,818		Matsumoto et al.	01-02-1996	
	BO	5,484,664		Kitahara et al.	01-16-1996	
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	BS	5,693,139		Nishizawa et al.	12-02-1997	
BT	5,705,224		Murota et al.	01-06-1998		
BU	5,711,811		Suntola et al.	01-27-1998		
BV	5,730,802		Ishizumi et al.	03-24-1998		
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Sheet 3 of 4

Application Number	09/678,266
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Filing Date	10/03/2000
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First Named Inventor	Ming Xi
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Group Art Unit	4762 2827
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Examiner Name Unassigned ZARNEKE

Attorney Docket Number	4714P1/AMI-11
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Application Number	unassigned 89/678266
Filing Date	Unassigned
First Named Inventor	Ming Xi
Group Art Unit	Unassigned 2827
Examiner Name	Unassigned ZARNEKE
Attorney Docket Number	4714 BA/AMI-00-11

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Sheet	1	of	2
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Application Number	unassigned
Filing Date	unassigned
First Named Inventor	Ming Xi
Group Art Unit	unassigned 2825
Examiner Name	unassigned 2APWA
Attorney Docket Number	4714 P1/AMI-00-11

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Sheet	2	of	2
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Sheet	3	of	4
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Application Number	09/678,266
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Filing Date	10/03/2000
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First Named Inventor	Ming Xi
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Group Art Unit	4762 2822
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Examiner Name	Unassigned ZARNEKE
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Attorney Docket Number	4714P1/AMI-11
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Sheet

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of

2

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Application Number	09/678,266
Filing Date	10/3/2000
First Named Inventor	Ming Xi
Group Art Unit	4702 2823
Examiner Name	unassigned 2
Attorney Docket Number	4714P1/AMI-11

U.S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

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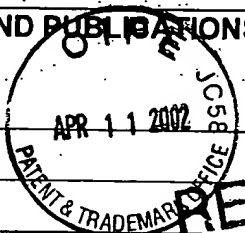
Date
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¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

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U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)		Docket No. APPM/4714.P1	Serial No. 09/678,266
SUPPLEMENTAL LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT		Applicant Kori, et al.	Confirmation No.: Unknown
(Use several sheets if necessary)		Filing Date October 30, 2000	Group 1782 2827
Examiner Unknown			

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*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
PH	A1	4,813,846	03/21/89	Helms	414	744.1	04/29/87
PH	A2	4,917,556	04/17/90	Stark et al.	414	217	05/26/89
PH	A3	4,951,601	08/28/90	Maydan, et al.	118	719	06/23/89
PH	A4	5,000,113	03/19/91	Wang et al.	118	723	12/19/86
PH	A5	5,186,718	02/16/93	Tepman et al.	29	25.01	04/15/91
PH	A6	5,205,077	04/27/93	Wittstock	51	165 R	08/28/91
PH	A7	5,234,561	08/10/93	Randhawa et al.	204	192.38	08/25/88
PH	A8	5,259,881	11/09/93	Edwards, et al.	118	719	05/17/91
PH	A9	5,286,296	02/15/94	Sato et al.	118	719	01/09/92
PH	A10	5,609,689	03/11/97	Kato et al.	118	719	06/03/96
PH	A11	5,667,592	09/16/97	Boitnott et al.	118	719	04/16/96
PH	A12	5,674,786	10/07/97	Turner et al.	437	225	06/05/95
PH	A13	5,695,564	12/09/97	Imahashi	118	719	08/03/95
PH	A14	5,730,801	03/24/98	Tepman et al.	118	719	08/23/94
PH	A15	5,788,447	08/04/98	Yonemitsu et al.	414	217	08/05/96
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PH	A19	5,866,213	02/02/99	Foster et al.	427	573	07/19/97
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PH	A21	5,882,165	03/16/99	Maydan et al.	414	217	09/10/97
PH	A22	5,882,413	03/16/99	Beaulieu et al.	118	719	07/11/97
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Examiner <i>[Signature]</i>	Date Considered 8/6/2
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(Use several sheets if necessary)				Filing Date October 30, 2000		Group 1702 2827	
Examiner Unknown							
Foreign Patent Documents							
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Examiner <i>David H. Jambor</i>				Date Considered <i>8/6/2</i>			
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Foreign Patent Documents

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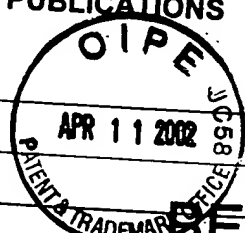
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Foreign Patent Documents



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Foreign Patent Documents

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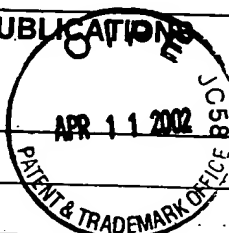
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Foreign Patent Documents

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CITED BY APPLICANT**

Doc. No.

APPM/4714.P1

Serial No.

09/678,266

Applicant

Kori, et al.

Confirmation No.:

Unknown

(Use several sheets if necessary)

Filing Date

October 30, 2000

Group

1762 2527

Examiner Unknown

Foreign Patent Documents**RECEIVED**

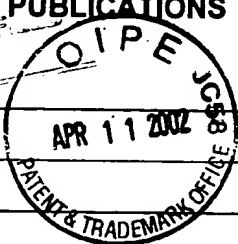
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Examiner

Date Considered

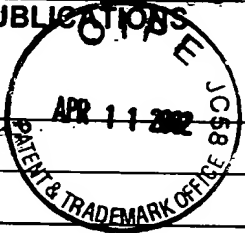
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U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)		APR 15 2002 TC 1700	Docket No. APPM/4714.P1	Serial No. 09/678,266
SUPPLEMENTAL LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT			Applicant Kori, et al.	Confirmation No.: Unknown
(Use several sheets if necessary)			Filing Date October 30, 2000	Group 17622827
Examiner Unknown		<div style="text-align: center;">  </div>		
OTHER ART				
*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.		
<i>PH</i>	C1	Ohba, et al., "Thermal Decomposition of Methylhydrazine and Deposition Properties of CVD TiN Thin Films", Conference Proceedings, Advanced Metallization for ULSI Applications in 1993, (1994), pp. 143-149		
<i>PH</i>	C2	Schepel, et al., "Low-temperature deposition of titanium nitride films from dialkylhydrazine-based precursors", Materials Science in Semiconductor Processing 2 (1999), pp. 149-157		
<i>PH</i>	C3	Suzuki, et al., "A 0.2-μm contact filing by 450°C-hydrazine-reduced TiN film with low resistivity", IEDM 92-979, pp. 11.8.1 – 11.8.3		
<i>PH</i>	C4	Suzuki, et al., "LPCVD-TiN Using Hydrazine and TiCl ₄ ", VMIC Conference (June 8-9, 1993), pp. 418-423		
<i>PH</i>	C5	IBM Tech. Disc. Bull. "Knowledge-Based Dynamic Scheduler in Distributed Computer Control, (June 1990), pp. 80-84		
<i>PH</i>	C6	IBM Tech. Disc. Bull. "Multiprocessor and Multitasking Architecture for Tool Control of the Advanced via Inspection Tools" (May 1992), pp. 190-191		
<i>PH</i>	C7	McGeachin, S., "Synthesis and properties of some β-diketimines derived from acetylacetone, and their metal complexes", Canadian J. of Chemistry, Vol. 46 (1968), pp.1903-1912		
<i>PH</i>	C8	Solanki, et al., "Atomic Layer deposition of Copper Seed Layers", Electrochemical and Solid State Letters, 3(10) (2000), pp. 479-480		
<i>PH</i>	C9	NERAC.COM Retro Search: Atomic Layer Deposition of Copper, dated October 11, 2001		
<i>PH</i>	C10	NERAC.COM Retro Search: Atomic Layer Deposition / Epitaxy Aluminum Oxide Plasma, dated October 2, 2001		
<i>PH</i>	C11	NERAC Search abstract of "Atomic Layer deposition of Ta and Ti for Interconnect Diffusion Barriers", by Rossnagel, et al., J. Vac. Sci. & Tech., 18(4) (July 2000)		
<i>PH</i>	C12	Abstracts of articles re atomic layer deposition		
<i>PH</i>	C13	Abstracts of search results re atomic layer deposition, search dated January 24, 2002		
<i>PH</i>	C14	Abstracts of articles re atomic layer deposition and atomic layer nucleation		
<i>PH</i>	C15	Abstracts of articles re atomic layer deposition and semiconductors and copper		
Examiner <i>[Signature]</i>		Date Considered 8/6/12		
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SUPPLEMENTAL LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT (Use several sheets if necessary)		Applicant Kori, et al.	Confirmation No.: Unknown
		Filing Date October 30, 2000	Group 1762 <i>2827</i>
Examiner Unknown			



OTHER ART

*Examiner Initial	Citation	Including Author, Title, Date, Pertinent Pages, Etc.
<i>ME</i>	C16	Abstracts of articles – atomic layer deposition
<i>ME</i>	C17	NERAC Search – Atomic Layer Deposition, search dated October 16, 2001
<i>ME</i>	C18	Bader, et al., "Integrated Processing Equipment", Solid State Technology, Cowan Pub., Vol. 33, No. 5 (May 1, 1990), pp. 149-154
<i>ME</i>	C19	Choi, et al., "The effect of annealing on resistivity of low pressure chemical vapor deposited titanium diboride", J. Appl. Phys. 69(11) (June 1, 1991), pp. 7853-7861
<i>ME</i>	C20	Choi, et al., "Stability of TiB ₂ as a Diffusion Barrier on Silicon", J. Electrochem. Soc. 138(10) (October 1991), pp. 3062-3067
<i>ME</i>	C21	"Cluster Tools for Fabrication of Advanced devices" Jap. J. of Applied Physics, Extended Abstracts, 22 nd Conference Solid State Devices and Materials (1990), pp. 849 – 852 XP000178141 (ARTICLE ON ORDER – TO BE PROVIDED)
<i>ME</i>	C22	"Applications of Integrated processing", Solid State Technology, US, Cowan Pub., Vol 37, No. 12 (December 1, 1994), pp. 45-47
<i>ME</i>	C23	Kitigawa, et al., "Hydrogen-mediated low temperature epitaxy of Si in plasma-enhanced chemical vapor deposition", Applied Surface Science (2000), pp. 30-34 (ARTICLE ON ORDER – TO BE PROVIDED)
<i>ME</i>	C24	Lee, et al., "Pulsed nucleation for ultra-high aspect ratio tungsten plugfill", Novellus Systems, Inc. (2001), pp. 1-2 (ARTICLE ON ORDER – TO BE PROVIDED)

Examiner <i>David A. Zurek</i>	Date Considered <i>8/6/02</i>
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U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)		Docket No. APPM/4714.P1	Serial No. 09/678,266
LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT (Use several sheets if necessary)		Applicant Kori, et al.	Confirmation No. 4642
Examiner Zarneke, D.		Filing Date 10/03/2000	Group 2827

U.S. Patent Documents

*Examiner Initial	Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
OH	A1 2001/0042799 A1	11/22/2001	Kim, et al.	239	553	02/02/2001
	A2					
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	A4					
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	A7					
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	A12					

Foreign Patent Documents

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						YES	NO
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	B2					<input type="checkbox"/>	<input type="checkbox"/>

OTHER ART

*Examiner Initial	Including Author, Title, Date, Pertinent Pages, Etc.
OH	C1 "Cluster Tools for Fabrication of Advanced Devices" Jap. J of Applied Physics, Extended Abstracts 22 nd Conference Solid State Devices and Materials (1990), pp. 849- 852
OH	C2 Kitigawa, et al., "Hydrogen-mediated low temperature epitaxy of Si in plasma-enhanced chemical vapor deposition", Applied Surface Science (2000), pp. 30-34
OH	C3 Lee, et al., "Pulsed nucleation for ultra-high aspect ratio tungsten plugfill", Novellus Systems, Inc. (2001), pp. 1-2 (COPY NOT AVAILABLE TO APPLICANT AT THIS TIME)
Examiner	Date Considered 8/6/2

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Alkaline Number

09/678,266

Filing Late

10/3/2000

First Named Inventor

Ming Xi

Group Art Unit

1702 2827

Examiner Name


unassigned **A FARNER**

Attorney Docket Number

4714P1/AMI-11

Examiner
Initials*Cite
No.

Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.

 τ^2 

CQ

Kitagawa et al. Hydrogen-mediated low-temperature epitaxy of Si in plasma-enhanced chemical vapor deposition, *Applied Surface Science*, pp. 30–4 (2000).

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Date
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Complete if Known

Application Number	unassigned
Filing Date	Unassigned
First Named Inventor	Ming Xi
Group Art Unit	Unassigned 2827
Examiner Name	Unassigned BARNEKE
Attorney Docket Number	4714 P1/AMI-00-11

(use as many sheets as necessary)

Sheet	1	of	2
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U.S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

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Application Number	unassigned
Filing Date	unassigned
First Named Inventor	Mina Xi
Group Art Unit	unassigned 2823
Examiner Name	unassigned 2APNOC
Attorney Docket Number	4714 P1/AMI-00-11

(use as many sheets as necessary)

Sheet 2 of 2

Attorney Docket Number	4714 P1/AMI-00-11
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OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS

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Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet	1	of	4
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Complete if Known

Application Number	09/678.866
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Filing Date	10/03/2000
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First Named Inventor	Ming Xi
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Group Art Unit	1762 2827
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Examiner Name	Unassigned ZARNEKE
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Attorney Docket Number	4714P1/AMI-11
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U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. 1	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
<i>OK</i>	AJ	4,058,430		Suntola et al.	11-15-1977	
<i>OK</i>	AK	4,389,973		Suntola et al.	06-28-1983	
<i>OK</i>	AL	4,413,022		Suntola et al.	11-01-1983	
<i>OK</i>	AM	4,767,494		Kobayashi et al.	08-30-1988	
<i>OK</i>	AN	4,806,321		Nishizawa et al.	02-21-1989	
<i>OK</i>	AO	4,840,921		Matsumoto	06-20-1989	
<i>OK</i>	AP	4,845,049		Sunakawa	07-04-1989	
<i>OK</i>	AQ	4,859,627		Sunakawa	08-22-1989	
<i>OK</i>	AR	4,861,417		Mochizuki et al.	08-29-1989	
<i>OK</i>	AS	4,876,218		Pessa et al.	10-24-1989	
<i>OK</i>	AT	4,993,357		Scholz	02-19-1991	
<i>OK</i>	AU	5,082,798		Arimoto	01-21-1992	
<i>OK</i>	AV	5,130,269		Kitahara et al.	07-14-1992	
<i>OK</i>	AW	5,166,092		Mochizuki et al.	11-24-1992	
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<i>OK</i>	AY	5,250,148		Nishizawa et al.	10-05-1993	
<i>OK</i>	AZ	5,256,244		Ackerman	10-26-1993	
<i>OK</i>	BA	5,270,247		Sakuma et al.	12-14-1993	
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<i>OK</i>	BC	5,281,274		Yoder	01-25-1994	

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FOREIGN PATENT DOCUMENTS

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)		Application Number	09/678,266
		Filing Date	10/03/2000
		First Named Inventor	Ming Xi
		Group Art Unit	1762 <i>2829</i>
		Examiner Name	Unknown <i>LARNEKE</i>
Sheet 4	of 4	Attorney Docket Number	4714P1/AMI-11

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

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Examiner Signature	<i>[Signature]</i>	Date Considered	8/6/12
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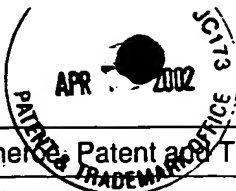
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U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)				Docket No. AMAT/4714.P1		Serial No. 09/678,266		
LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT				Applicant Xi, et al.				
(Use several sheets if necessary)				Filing Date October 03, 2000		Group 1762 2827		
Examiner Unknown								
U.S. Patent Documents								
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DA	A1	4,486,487	12/04/84	Skarp	428	216	04/25/1983	
DA	A2	4,829,022	05/09/89	Kobayashi et al.	437	107	12/09/1986	
DA	A3	4,834,831	05/30/89	Nishizawa et al.	156	611	09/04/1987	
DA	A4	4,838,983	06/13/89	Schumaker et al.	156	613	03/18/1988	
DA	A5	4,838,993	06/13/89	Aoki et al.	156	643	12/03/1987	
DA	A6	4,859,625	08/22/89	Nishizawa et al.	437	81	11/20/1987	
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DA	B2	01/40541 A1	06/07/2001	WO	C23C	16/40		X
DA	B3	01/36702 A1	05/25/2001	WO	C23C	16/00		X
DA	B4	01/29893 A1	04/26/2001	WO	H01L	21/768		X
DA	B5	01/29891 A1	04/26/2001	WO	H01L	21/768		X
OTHER ART								
*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.						
DA	C1	Hultman, et al., "Review of the thermal and mechanical stability of TiN-based thin films", <i>Zeitschrift Fur Metallkunde</i> , 90(10) (Oct. 1999), pp. 803-813.						
DA	C2	Klaus, et al., "Atomic Layer Deposition of SiO ₂ Using Catalyzed and Uncatalyzed Self-Limiting Surface Reactions", <i>Surface Review & Letters</i> , 6(3&4) (1999), pp. 435-448.						
Examiner					Date Considered 8/6/2			
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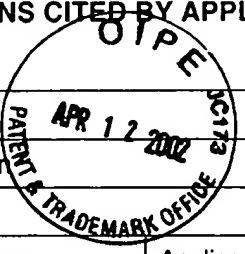
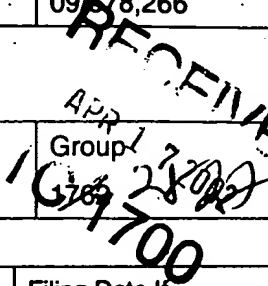
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DL	A14	5,246,536	09/21/93	Nishizawa et al.	156	610	03/10/1989	
DL	A15	5,254,207	10/19/93	Nishizawa et al.	156	601	11/30/1992	
DL	A16	5,296,403	03/22/94	Nishizawa et al.	437	133	10/23/1992	
DL	A17	5,311,055	05/10/94	Goodman et al.	257	593	11/22/1991	
DL	A18	5,316,615	05/31/94	Copel	117	95	03/09/1993	
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DL	A20	5,374,570	12/20/94	Nasu et al.	437	40	08/19/1993	
DL	A21	5,438,952	08/08/1995	Otsuka	117	84	01/31/1994	
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DL	A24	5,443,647	08/22/95	Aucoin et al.	118	723 ME	07/11/1994	
DL	A25	5,455,072	10/03/95	Bension et al.	427	255.7	11/18/1992	
DL	A26	5,469,806	11/28/95	Mochizuki et al.	117	97	08/20/1993	
DL	A27	5,503,875	04/02/96	Imai et al.	427	255.3	03/17/1994	
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DL	B6	01/29280 A1	04/26/2001	WO	C23C	16/32		X
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DL	B8	01/27346 A1	04/19/2001	WO	C23C	16/44		X
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DL	C3	Yamaguchi, et al., "Atomic-layer chemical-vapor-deposition of silicon dioxide films with extremely low hydrogen content", <i>Appl. Surf. Sci.</i> , Vol. 130-132 (1998), pp. 202-207.						
DL	C4	George et al., "Surface Chemistry for Atomic Layer Growth", <i>J. Phys. Chem.</i> , Vol. 100 (1996), pp. 13121-131.						
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DA	A30	5,540,783	07/30/96	Eres et al.	118	725	05/26/1994	
DA	A31	5,601,651	02/11/97	Watabe	118	715	12/14/1994	
DA	A32	5,616,181	04/01/97	Yamamoto et al.	118	723 ER	11/21/1995	
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DA	A38	5,796,116	08/18/98	Nakata et al.	257	66	07/25/1995	
DA	A39	5,807,792	09/15/98	Ilg et al.	438	758	12/18/1996	
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DA	B11	00/79019 A1	12/28/2000	WO	C23C	16/00		X
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DA	C5	George, et al., "Atomic layer controlled deposition of SiO ₂ and Al ₂ O ₃ using ABAB...binary reaction sequence chemistry", <i>Appl. Surf. Sci.</i> , Vol. 82/83 (1994), pp. 460-467.						
DA	C6	Wise, et al., "Diethyldiethoxysilane as a new precursor for SiO ₂ growth on silicon", <i>Mat. Res. Soc. Symp. Proc.</i> , Vol. 334 (1994), pp. 37-43.						
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		A41	5,835,677	11/10/98	Li et al.	392	401	10/03/1996
		A42	5,855,675	01/05/99	Doering et al.	118	719	03/03/1997
		A43	5,858,102	01/12/99	Tsai	118	719	02/14/1998
		A44	5,879,459	03/09/99	Gadgil et al.	118	715	08/29/1997
		A45	5,904,665	05/18/1999	Nguyen, et al.	438	687	07/17/1997
		A46	5,916,365	06/29/99	Sherman	117	92	08/16/1996
		A47	5,923,056	07/13/99	Lee et al.	257	192	03/12/1998
		A48	5,923,985	07/13/99	Aoki et al.	438	301	01/14/1997
		A49	5,925,574	07/20/99	Aoki et al.	437	31	04/10/1992
		A50	5,942,040	08/24/99	Kim et al.	118	726	08/27/1997
		A51	5,947,710	09/07/1999	Cooper, et al.	418	63	06/16/1997
		A52	5,972,430	10/26/99	DiMeo, Jr. et al.	427	255.32	11/26/1997
		A53	6,001,669	12/14/99	Gaines et al.	438	102	07/21/1992
		A54	6,174,377	01/16/2001	Doering, et al.	118	729	01/04/1999

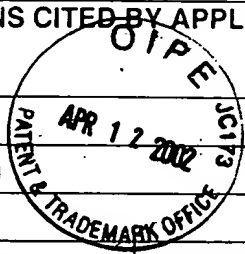
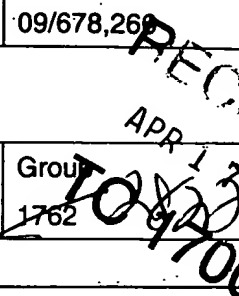
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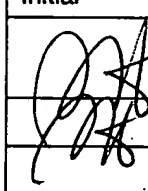
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	C7 Niinisto, et al., "Synthesis of oxide thin films and overlayers by atomic layer epitaxy for advanced applications", <i>Mat. Sci. & Eng.</i> , Vol. B41 (1996), pp. 23-29.
	C8 Ritola, et al., "Perfectly conformal TiN and Al ₂ O ₃ films deposited by atomic layer deposition", <i>Chemical Vapor Deposition</i> , Vol. 5(1) (January 1999), pp. 7-9.
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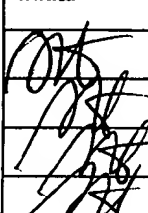
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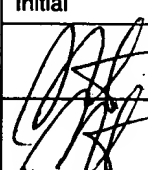
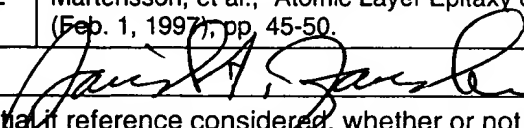
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	A55	6,174,809	01/16/2001	Kang, et al.	438	682	12/15/1998	
	A56	6,203,613	03/20/2001	Gates, et al.	117	104	10/19/1999	
	A57	6,207,302	03/27/2001	Sugiura, et al.	428	690	03/02/1998	
	A58	6,248,605	06/19/2001	Harkonen, et al.	438	29	06/02/1999	
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	A67	2001/0011526	08/09/2001	Doering, et al.	118	729	01/16/2001	
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	B17	96/18756 A1	06/20/1996	WO	C23C	16/08		X
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	C9	Min, et al., "Atomic layer deposition of TiN thin films by sequential introduction of Ti precursor and NH/sub3", <i>Symp.: Advanced Interconnects and Contact Materials and Processes for Future Integrated Circuits</i> (Apr. 13-16, 1998), pp. 337-342.						
	C10	Klaus, et al., "Atomic Layer Deposition of Tungsten using Sequential Surface Chemistry with a Sacrificial Stripping Reaction," <i>Thin Solid Films</i> 360 (2000), Pages 145 - 153, (Accepted Nov. 16, 1999).						
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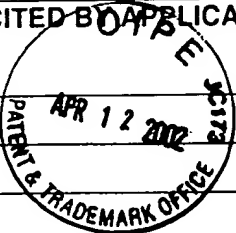
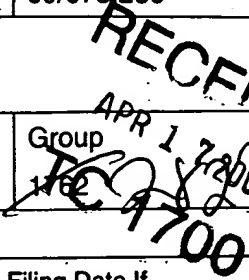
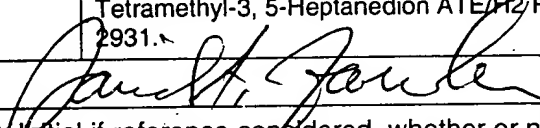
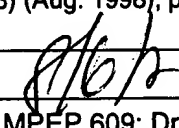



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	A68	2001/0031562	10/18/2001	Raaijmakers, et al.	438	770	02/22/2001
	A69	2001/0034123	10/25/2001	Jeon, et al.	438	643	04/06/2001
	A70						
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	B19	93/02111 A1	02/04/1993	WO	C08F	4/78		X
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	C11	Min, et al., "Metal-Organic Atomic-Layer Deposition of Titanium-Silicon-Nitride Films", <i>Applied Physics Letters</i> , American Inst. Of Physics, Vol 75(11) (Sept. 13, 1999).
	C12	Martensson, et al., "Atomic Layer Epitaxy of Copper on Tantalum", <i>Chemical Vapor Deposition</i> , 3(1) (Feb. 1, 1997), pp 45-50.
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	C13	Ritala, et al. "Atomic Layer Epitaxy Growth of TiN Thin Films", <i>J. Electrochem. Soc.</i> , 142(8) (Aug. 1995), pp. 2731-737.						
	C14	Elers, et al., "NbC15 as a precursor in atomic layer epitaxy", <i>Appl. Surf. Sci.</i> , Vol. 82/83 (1994), pp. 468-474.						
	C15	Lee, "The Preparation of Titanium-Based Thin Film by CVD Using Titanium Chlorides as Precursors", <i>Chemical Vapor Deposition</i> , 5(2) (Mar. 1999), pp. 69-73.						
	C16	Martensson, et al., "Atomic Layer Epitaxy of Copper, Growth & Selectivity in the Cu (II)-2,2,6,6-Tetramethyl-3, 5-Heptanedion ATE/H ₂ Process", <i>J. Electrochem. Soc.</i> , 145(8) (Aug. 1998), pp. 2926-2931.						
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	B32	196 27 017	01/09/1997	DE	H01L	21/283	X
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	C17	Min, et al., "Chemical Vapor Deposition of Ti-Si-N Films with Alternating Source Supply", <i>Mat., Res. Soc. Symp. Proc.</i> , Vol. 564 (Apr. 5, 1999), pp. 207-210					
	C18	Bedair, "Atomic layer epitaxy deposition processes", <i>J. Vac. Sci. Technol.</i> 12(1) (Jan/Feb 1994)					
	C19	Yamaga, et al., "Atomic layer epitaxy of ZnS by a new gas supplying system in a low-pressure metalorganic vapor phase epitaxy", <i>J. of Crystal Growth</i> 117 (1992), pp. 152-155					
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